

Notice of References Cited	Application/Control No. 10/711,779	Applicant(s)/Patent Under Reexamination LIU, CHI-YUAN	
	Examiner VAN T. PHAM	Art Unit 2627	Page 1 of 1

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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